

<b>AMENDMENT TRANSMITTAL LETTER (Large Entity)</b> Applicant(s): Fengyan Zhang, and Sheng Teng Hsu			Docket No. <b>SLA0804</b>		
Serial No 10/677,008	Filing Date September 30, 2003	Examiner Renee R. Berry	Group Art Unit 2818		
Invention: One Mask P/PCMO/Pt Stack Etching Process for RRAM Applications					
<b>TO THE COMMISSIONER FOR PATENTS:</b>			<b>RECEIVED</b> <b>CENTRAL FAX CENTER</b> <b>DEC 23 2004</b>		
Transmitted herewith is an amendment in the above identified application. The fee has been calculated and is transmitted as shown below.					
<b>CLAIMS AS AMENDED</b>					
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER OF EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	20 -	20 =	0	x \$50.00	\$0.00
INDEP. CLAIMS	3 -	3 =	0	x \$200.00	\$0.00
Multiple Dependent Claims (check if applicable) _____					\$0.00
<b>TOTAL ADDITIONAL FEE FOR THIS AMENDMENT</b>					\$0.00

☒ No additional fee is required for amendment.

☐ Please charge Deposit Account No. 19-1457 in the amount of \$0.00.

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☐ A check in the amount of \_\_\_\_\_ to cover the filing fee is enclosed.

☒ The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 19-1457.

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☒ Any additional fees required under 37 C.F.R. 1.16.

☒ Any patent application processing fees under 37 C.F.R. 1.17.

\_\_\_\_\_  
David C. Ripma, Reg. No. 27,672

Dated: December 23, 2004

I hereby certify that this correspondence is being facsimile transmitted to the United States Patent and Trademark Office under 37 C.F.R. §1.8 at Fax No. (703) 872-9306 on December 23, 2004.

David C. Ripma, Reg. No. 27,672

Note: Each paper must have its own certificate of transmission, or this certificate must identify each submitted paper. The papers submitted include:

<input checked="" type="checkbox"/> This Amendment Transmittal Letter (Include Duplicate)	2 page(s)
<input checked="" type="checkbox"/> Response under 37 CFR § 1.111	14 page(s)
<input type="checkbox"/> Attachments	0 page(s)
<input type="checkbox"/>	pages

**Total pages, including this Transmittal: 16**

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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: 10/677,008

Confirmation Number: 7272

Applicant: Fengyan Zhang *et al.*

Filed: September 30, 2003

Group #: 2818

Examiner: Renee R. Berry

Docket No: SLA.0804

Customer No: 27518

For: *One-Mask Pt/PCMO/Pt Stack Etching Process for RRAM Applications*

MS AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, Virginia 22313-1450

## RESPONSE TO OFFICE ACTION UNDER 37 C.F.R. § 1.111

## Introductory Comments

In response to the Office Action dated October 7, 2004, please amend the above-identified Application as follows:

**Amendment to the Specification** None**Amendment to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.**Amendment to the Drawings** None**Remarks/Arguments** begin on page 10 of this paper.**An Appendix** is not included.